

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

OXIDATION METHOD FOR ALTERING A FILM STRUCTURE
AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH

Application Number :

Confirmation Number:

First Named Applicant: Michael Belyansky

Attorney Docket Number: FIS920030286US1,

Art Unit:

Examiner:

Search string: (5847419 or 6316820 or 6504235 or 6538278 or 20020197803).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
LP	1	5847419	1998-12-08	Imai, et al.			
I	2	6316820	2001-11-13	Schmitz, et al.			
J	3	6504235	2003-01-07	Schmitz, et al.			
✓	4	6538278	2003-03-25	Chau			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
LP	- 1	20020197803	2002-12-26	Leitz, et al.			

Signature

Examiner Name	Date
Long Nam	8/11/04